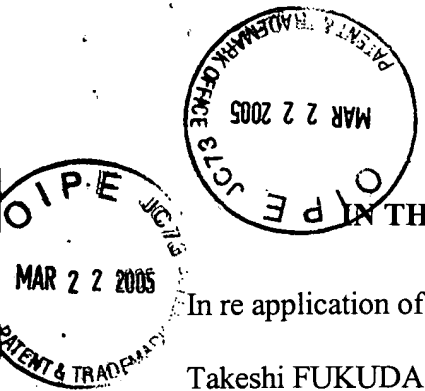


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**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q76740

Takeshi FUKUDA, et al.

Appln. No.: 10/644,827

Group Art Unit: 2883

Confirmation No.: 6185

Examiner: Ryan A. LEPISTO

Filed: August 21, 2003

For: OPTICAL WAVEGUIDE IN THE INTERIOR OF SILICA GLASS  
AND METHOD FOR FORMING OPTICAL WAVEGUIDE (As Amended)

**AMENDMENT UNDER 37 C.F.R. §1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated October 12, 2004, please amend the above-identified application as follows on the accompanying pages.

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